



<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Attorney Docket No.: 46884-5317		Serial No.: 10/507,321		
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<b>U.S. PATENT DOCUMENTS</b>								
*Examiner Initial		Document Number	Date	Name	Class	Sub Class	Filing Date	
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		Document Number	Date	Country	Class	Sub Class	<u>Translation</u> <b>YES</b> <b>NO</b>	
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Examiner      /Elias Ullah/ (06/19/2007)				Date Considered      06/19/2007				
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R. Sugiura et al., "The Stealth Dicing Technologies and Their Applications," Proceedings of the 63<sup>rd</sup> Laser Materials Processing Conference, May 2005, pp. 115-123, with English abstract.

A. Ishii et al., "CO2 Laser Processing Technology, Nikkan Kogyo Publishing Production, December 21, 1992, pps. 63-65 (with partial English translation)

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K. Hayashi, "Inner Glass Marking by Harmonics of Solid-state Laser," Proceedings of 45<sup>th</sup> Laser Materials Processing Conference, December 1998, pps. 23-28, with English abstract.

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		2001-250798	September 14, 2001	Japan			Abstract	
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	JP 4-188847	July 7, 1992	JP			Abstract	
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	JP 2002-158276	May 31, 2002	JP			Abstract	
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	Document Number	Date	Country	Class	Sub Class	Translation	
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	2003-334812	Nov. 25, 2003	Japan			X (abstract)	
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	11-163097	June 18, 1999	Japan			X (abstract)	
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	2005-159378	June 16, 2005	Japan			X (abstract)	
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<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
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Group Art Unit: Unassigned			

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